



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 09/698,317
Filed: October 27, 2000
Inventor(s):
Choi et al.

§ Examiner: Unknown
§ Group/Art Unit: 2859
§ Atty. Dkt. No: 5119-08601
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Title: HIGH PRECISION
ORIENTATION
ALIGNMENT AND GAP
CONTROL STAGES FOR
IMPRINT LITHOGRAPHY
PROCESSES

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8
DATE OF DEPOSIT: 12-27-01
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail on the date indicated above and is addressed to: Commissioner for Patents Washington, D.C. 20231
<i>Jo Ann Scott</i> Jo Ann Scott

NOTICE OF CHANGE OF ADDRESS

Commissioner for Patents
Washington, D.C. 20231

Sir:

Applicant respectfully requests the Commissioner to change the correspondence address
for the above identified patent application. Applicant's old correspondence address was:

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Choi, et al.
90/698,317

If there are any questions regarding this matter, please contact me at the telephone number provided below.

Respectfully submitted,



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